





**Exposure-masking system** USER MANUAL - UVK2-4P-2023-01

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The UV-KUB 2, 4 inches version, is a very compact exposure and masking system equipped with a LED based optical head, collimated and homogeneous.

Controlled by touchscreen, the UV-KUB 2 ensures safety through an entirely closed exposure chamber, with both hard or soft contact modes available.

Thanks to its hermetic configuration, this equipment doesn't need to be installed in a clean room.



## **Summary**

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Compliance

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## LV-KLB Z 4" version

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#### Legend of the user manual





## Notes

## Warranty

The UV-KUB 2 is guaranteed for one year (from date of on-site installation). This warranty covers all material and/or manufacturing defects if used under normal conditions.

Optionally, the company KLOE SAS will repair or replace any part of the UV-KUB 2 proven to be defective during the period covered by the warranty, given the equipment was properly used.

Any intervention on the part of a person not authorized by the company KLOE SAS, intended to modify or repair the UV-KUB 2 machine voids the warranty. Similarly, the loss of or damage to the control label of the machine door located between the cover and back panel voids the warranty.

The manufacturer KLOE SAS is not responsible for any indirect damage.

In the case of equipment malfunction or to obtain information and/or advice for the use of the UV-KUB 2, please contact the company KLOE SAS at the following address. Any defective part must be returned after agreement with KLOE SAS technical support to the following address:

#### **KLOE SAS - S.A.V. 2-4 rue des Arbousiers 34 270 SAINT-MATHIEU-DE-TREVIERS - FRANCE** Tel: (33) (0)4 67 82 19 10 - email: sav@kloe-france.com

#### WARNING!

The company KLOE SAS cannot guarantee the accuracy and reliable operation of the machine if the normal conditions of use specified in the UV-KUB 2 equipment manual are not met. The framed annotations that appear throughout this manual should be read and followed scrupulously.







## Complaints

For customer service, please contact the company KLOE SAS. KLOE SAS assumes no responsibility for damage during transport.

Throughout the duration of the warranty, KLOE SAS will repair or replace damaged parts free o charge unless said damage is caused by abnormal equipment use. If necessary, the company KLOE SAS may instruct a person to perform an on-site intervention to carry out any repairs. If an on-site intervention should take place, travel expenses for the KLOE SAS technician will be borne by KLOE SAS itself throughout the duration of the warranty unless it appears that the malfunction i actually related to a breach of normal use of the UV-KUB 2.

In all cases, the company KLOE SAS will determine if the failure is due to misuse, a modification an accident, improper operation or abnormal handling of the UV-KUB 2 device in which case any repair will be charged in full to the user of the machine and every piece repaired will be returned with prepayment of postage.



### Compliance

İy	DECLARATION OF CONFORMITY CE
of	Declaration of conformity
iy In	In accordance with Directive 98/37/EC of the European Parliament and the Council of June 22, regarding the approximation of laws of member States relating to machinery,
e	Company : KLOE SAS
15	Certifies that the equipment : UV-KUB 2, Masking Lithography Equipment
٦,	Complies with :
iy	<ul> <li>Regulatory provisions defined by Annex I of the European Directive 98/37/EC.</li> </ul>
ĥ	<ul> <li>The rules defined in Annex I introduced in the Labour Code by Article R.233-84.</li> </ul>
	<ul> <li>The rules of the decree of November 14, 1988 on the protection of individuals against the da of electric machines.</li> </ul>
	<ul> <li>Directive 89/336/EEC of May 3, 1989, on the approximation of laws of member States relat electromagnetic compatibility.</li> </ul>
	<ul> <li>Standard NF EN 60-204, relating to machine electrical equipment.</li> </ul>
	Manufacturer Contact
	Adress : KLOE SAS
	2-4 rue des Arbousiers 34 270 Saint-Mathieu-de-Treviers - France Paul Coudray

Email : contact@kloe-france.com

Phone : (33) (0)4 67 82 19 10

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# The equipment

### The equipment 1



Perfo	rmances
Resolution	1µm
Divergence angle	< 2°
Number of programmable cycles	10
Exposure cycle (continuous or cyclic)	From 1s to 1h
Processes	Hard (physical) or soft (proximity) contact processes

ι	JV-LED source	
Wavelength	365nm +/- 5nm	
Homogeneous exposure	+/- 5%	
Lifetime of the LEDs	> 10000 hours	
Power density	40mW/cm <sup>2</sup> +/- 10%	

Working/W	Vriting surface
Working surface	4" wafer
Accepted masks size	up to Ø 5"
Accepted substrate size	Ø 2" - Ø 4" and 50 x 50mm - 100 x 100mm
Mask/substrate measuring distance resolution	0.5µm
Substrate warm-up during exposure	< 1°C
Compatible photoresist	All photoresists at 365nm including SU8, Shipl AZ Resist, K-CL resist (developed by Kloe)





5.7" touchscreen.

#### WARNING!

The use of the stylet provided with the equipment and adapted to capacitive screens is strongly recommended. Any damage due to a misuse will not be supported by Kloe.

ley,

Emergency stop button.

Drawer for loading insertion of substrate and photomask in the exposure chamber.

Drawer opening command (IR sensor).

ON/OFF switch.



The equipment



### **Rear panel**



Ventilation grid.

#### WARNING!

Leave at least 10cm (4") of free space around this area for optimum cooling of the device.

Sub D plug (for Kloe maintenance service only).

#### WARNING!

No cable should be connected to this plug without Kloe's permission.

Power plug, equipped with a switch.

#### WARNING!

Turn the connector switch off to ensure that the machine is completely off, when it's not use for several hours.



### Side panels



Ventilation grids.

#### WARNING!

Leave at least 10cm (4") of free space around this area for optimum cooling of the device.

#### **GOOD TO KNOW**

The LED cooling fan is activated only during exposure and stops a few minutes after the interruption.

Side door: provides access to the exposure chamber to ease cleaning.

#### WARNING!

Only acces the exposure chamber when the machine is turned off. Should the door be opened while in use, a detector shuts off general power to the machine to avoid any accidental user exposure to UV radiation. Do not open the door when in progress as the exposure would be irretrievably stopped.









## the chawer







For more safety and to avoid damaging the machine, the drawer's opening system is equipped with a torque limiter. In case a person or an object is blocking the opening or closing of the drawer, the system will interrupt the operation and wait for the user to activate again the drawer's opening command.





#### The static photomask holder



The mask holder is divided into **3 support areas**. It accepts square photomasks from 125 to 127.3mm.

A material recess is provided to allow easy gripping of the mask by lifting an edge.

#### **GOOD TO KNOW**

For photomasks of smaller dimensions, an optional adaptater must be used.

#### WARNING!

The parallelism between the photomask and the substrate is factory set and must not be modified by the user in any way.





### The mobile substrate holder



2 imprints for 2 standard sizes of substrates:

imprint 1 for 4" wafer,

imprint 2 for 2" wafer,

recesses on each side of the imprints: ease the removal of substrates by using a clamp.



#### **GOOD TO KNOW**

To facilitate their positioning, both imprints have grooves corresponding to each wafer groove.

for wafer 2"

for wafer 4"





#### Automated adjusting system for masking distance

#### Static mask holder

Mobile substrate holder

Mask

#### **Substrate**

A motorized system built into the drawer, adjusts the masking distance via the touchscreen interface with a +/- 5µm accuracy. The distance between the **footprint of the substrate holder** and the mask support area depends on the substrate type used.

#### **GOOD TO KNOW**

By default, the UV-KUB 2 is configured to operate with 4 inches wafers. The footprint for 2" wafers is 150µm lower than the footprint for 4" wafers. When using a 2" wafer, remember to remove 150µm to the calculation of the total thickness of the sample.





#### Focus on... the drawer 2





During a masking, the user must enter the masking distance value, defined by the distance between:

the plane defined by the working side of the mask,

and the plane defined by the wafer surface to be exposed.

To optimally adjust the masking distance, the user must perfectly know the total stack thickness consisting of layers and substrate.





#### Photodetector



By measuring the incident illumination at the substrate holder level, integrated) confirms that the LEDs are correctly operating.

the photodetector (drawer

#### **GOOD TO KNOW**

These measurements can only take place in the absence of the wafer.







# Starting-up







#### Use conditions specified by the manufacturer

The UV-KUB 2 is a photolithography equipment that can be used as:

- a simple UV flood exposure system,
- <u>a masker</u>

The machine is designed for use with standard substrate wafer types of 4 inches or 2 inches in diameter. The UV-KUB 2 also works with substrates of thicknesses up to 2 mm in masking mode and up to 11.5 mm in simple exposure mode.

The use of masks with external side dimensions smaller than 5", require a mask adaptor not provided with the machine.

It is strongly advised to use the stylus supplied with the machine when using the touchscreen, and to prevent any finger pressure to avoid irreversibly damaging the screen.

#### **Prior checkings**

Make sure to place the UV-KUB 2 on a stable and robust support and and make sure to prevent from any excessive vibrations generated by other equipment, or fans and air conditioner. This in order to preserve the mechanical factory settings precision and to not disrupt the precise positioning of the substrate holder when using the masking mode.

The equipment must not be placed in proximity of heat source.

A proper working of the machine is guaranteed with an **ambient room temperature from 15 to** 27°C. Beyond, the nominal technical specifications may change and equipment lifetime may be affected.







Maintain a distance of 4 inches or more between other equipment and the UV-KUB areas fitted with ventilation grids.

#### Ensure that no objects block the front drawer.

Provide access to the side door in order to clean the exposure chamber.

- Ensure that the side door is completely closed, failing to will prevent the machine from starting. 4
- 5 Make sure the power cord is connected to the outlet.

Press the **power button** on the front of the machine.

On the rear panel, check that the power plug switch is on position 1.

#### **GOOD TO KNOW**

homepage screen appears, the user can then display the main menu and open **Once the** the drawer by pressing the screen.









Main menu description

Masking: by selecting this menu, you can then adjust the distance between the substrate and the mask and proceed to an exposure.

Full surface exposure: enables to realize a simple UV exposure of the entire substrate working surface.

**Settings:** to check the characteristics of the UV-KUB component elements.









# Full Surface exposure





#### When use the Full surface exposure?

The Full surface exposure mode enables simple UV exposure of the entire substrate working surface, in order to process bondings of optical chips, fiber matrix, pigtailing...

#### WARNING!

Once you have coated your resist on the substrate, and after the resin has dried, remember to remove the edge bead of the resin before loading the substrate in the UV-KUB 2, in order to prevent the resin from running onto the substrate holder and damaging it.

#### Substrate loading

Load the substrate on the substrate holder.

#### WARNING!

Check for absence of dust before putting the substrate in place.

#### **GOOD TO KNOW**

Substrates can be of all shapes (round, square) and all sizes up to 100 x 100mm.





### **GOOD TO KNOW**

When using a silicon wafer, enter the substrate at the edges, gently place it on the substrate holder and position the substrate with a clamp so that its groove corresponds to that of the housing.

Make sure before proceeding that the wafer is completely trapped in its housing.



**Full Surface** menu: the drawer closes. You can choose between launching a **New** Click on Cycle or Memory, to access the pre-registered cycles.









Exposure cycles settings

	Pulse Continuous	
	T 4" version	
K	LOÉ	

The UV-KUB 2 allows the user to choose between:

a continuous exposure of the substrate during an adjustable time period,

or to emit light pulses of adjustable duration separated by a time pause also configurable.



*Continuous exposure* 

Set the time

CONTINU • Duration = 10	IOUS MODE	•	
4" version			
		٦	

duration is expressed in hours (h), minutes (m), seconds (s) and is adjustable between The 1s and 1h by selecting the numbers/letters on the touchscreen keyboard.

#### WARNING!

It is essential to specify the units, otherwise the system will indicate "Input error!". <u>Ex</u>: 1m30s

Confirm your selection by touching the "V" validation button on the screen, or correct it by touching the "C" correction button as many times as are necessary.



#### **Full surface exposure** 4



	<ul> <li>Duration = 10s</li> <li>Power (in %) = 100</li> </ul>	Ì
•		
	4" version	
		_

**Power** is expressed as a percentage of the maximum power emitted by the LED.

It is adjustable between 5 and 100% by selecting the numbers on the keyboard.

#### **GOOD TO KNOW**

There is no unit of measurement, just enter and confirm the value. Ex: 45% can be entered by pressing 4 then 5 then V to validate.

#### **GOOD TO KNOW**

If you want to finally change the duration of exposure, just click the box in front of DURATION with the stylus so you can change the setting. You can thus navigate from one setting to another by clicking the corresponding boxes.









#### The exposure cycle is defined by successions of light pulses separated by time pauses.

To set a pulse exposure, you must indicate:

- the desired number of pulses: Cycles,
- the light pulse duration: ON Time,
- the pause duration between two pulses: **OFF Time.**

Then adjust the exposure power from 5% to 100%.

#### **GOOD TO KNOW**

By clicking one box with the stylus, one accesses the corresponding setting in order to change it.







Confirm settings

Confirm settings - Continuous exposure

Confirm settings - Pulse exposure





A summary settings menu appears and offers to perform three operations:

> **New:** returns the user to the menu to choose the exposure cycle. The user can create multiple exposure cycles in succession and store them one after the without other through the complete exposure setup each time.

> Save: allows the user to store the settings you just entered in the internal memory machine so you can reuse thereafter.

#### **GOOD TO KNOW**

You can store up to ten exposure cycles (pulse or continuous). If all memory locations are free, the boxes will be white with the indication Empty. If you want to save your cycle onto an already existing cycle, you will be asked to override.

**Insolate:** confirms the previously entered settings.

#### **GOOD TO KNOW**

Before launching the exposure, you are asked if you want to open the drawer and check your sample.













### Exposure in progress

	EXPOSURE IN PROGRESS CONTINUOUS MODE	
	<ul> <li>Duration = 10s</li> <li>Power (in %) = 100</li> </ul>	
	<ul> <li>Led Temperature = 23°C</li> <li>Wafer Temperature = 23°C</li> </ul>	*
	Time left = 04s	
-		
	<b>4</b> " version	
	<b>4</b> '' version	

During exposure, the screen displays a summary of the exposure settings:

- the temperature of the exposure chamber and the LEDs are permanently controlled and displayed,
- a timer lets you know the time remaining prior to the end of exposure.

#### WARNING!

Do not attempt to open the side door during exposure. The power to the machine will be automatically shut off to protect the user from UV radiation, and the exposure cycle will be terminated without possible return or memorization.



#### **Exposure interruption**

EXPOSURE IN PROGRESS	
CONTINUOUS MODE     Duration = 10s     Power (n %) = 100	
<ul> <li>Led Temperature = 23°C</li> <li>Wafer Temperature = 23°C</li> </ul>	<b>×</b>
Time left = 04s	
4" version	
KLŌĖ	

#### An exposure can be terminated for three reasons:

- rupture of the power supply,
- machine error: see chapter Troubleshootings: Error messages,
- voluntary user pause.

#### **GOOD TO KNOW**

To stop an exposure, press the emergency stop button on the right of the touch screen. In this case the machine will stop the exposure and will suggest to either restart or cancel the exposure. If you decide to restart the exposure, the UV-KUB will continue the originally defined cycle.



**Full surface exposure** 4 🚩



#### Exposure end

- At the end of the exposure, a buzzer sounds two long tones and the screen flashes.
- Simply touch the screen to open the drawer and retrieve the substrate.

#### **GOOD TO KNOW**

To retrieve the substrate, in the case of a wafer, pass the wafer clamp under the substrate by the recess provided for this purpose in the substrate holder.

Touch the screen to go to the next step.





While the drawer is still open, two choices are offered:

- To renew the exposure, with the same settings:
  - load a new substrate in the drawer,
  - **Continue:** a new exposure will be automatically launched with the identical settings - click on to those of the earlier exposure.
  - If you are finished, simply select **Cancel** to return to the UV-KUB 2 main screen.













# Nasking







#### When use the Masking mode?

This mode is use to realize the first level of masking.

#### WARNING!

Once you have coated your resist on the substrate, and after the resin has dried, remember to remove the edge bead of the resin before loading the substrate in the UV-KUB 2, in order to obtain the best possible results.

#### Substrate loading

Load the substrate on the substrate holder.

#### WARNING!

Check for absence of dust before putting the substrate in place.

#### **GOOD TO KNOW**

Substrates can be of all shapes (round, square) and all sizes up to 100 x 100mm.



### **GOOD TO KNOW**

When using a silicon wafer, enter the substrate at the edges, gently place it on the substrate holder and position the substrate with a clamp so that its groove corresponds to that of the housing.

Make sure before proceeding that the wafer is completely trapped in its housing.

#### Photomask loading









The UV-KUB 2 mask holder has three support areas for receiving the mask.

Lay the corners of the mask against the two areas opposite the wafer groove.

Let the mask slowly sit maintaining it,

until it makes contact with the **third support area**.

#### **GOOD TO KNOW**

The chrome face of the mask, including the patterns, should be placed upside down, against the substrate.



#### **GOOD TO KNOW**

In the case of mask use for side dimensions smaller than 5", it is essential to use a mask adapter not included with the UV-KUB 2.

The mask adapter is positioned on the mask holder in the same way as standard masks. The positioning of non-standard masks in the adapter takes place in the same way.

#### WARNING!

Using an adapter mask affects masking distance adjustment.



Click on







#### Setting the mask to substrate distance

#### **GOOD TO KNOW**

The drawer is open during all the mask to substrate distance setting.



Enter the total thickness of the **sample** (substrate + layers).

#### **GOOD TO KNOW**

When using a 2" wafer, remember to remove 150µm to the calculation of the total thickness of the sample: substrate + layers - 150µm

#### **GOOD TO KNOW**

It is essential to know as precisely as possible the thickness of your sample (substrate + resin) in order to precisely control the masking distance.





Then enter the masking distance.

#### **GOOD TO KNOW**

If the values you have chosen do not correspond to the values accepted by the UV-KUB 2, an error message will be displayed indicating the min and max values accepted by the machine.

Click on Validate. The substrate holder will rise and position itself at the chosen masking distance.

#### WARNING!

While leaving the drawer door open during a substrate holder distance adjustment, make sure that nothing hinders the movement of the substrate carrier or you may risk damaging the motorized moving device.

Once the wafer is in position, you can click on:

cancel if you want to go back to the **Masking Distance Adjustment,** 

continue to go to the next step: the drawer closes. You can choose between New Cycle or Memory.









Exposure cycles settings

Pulse	

The UV-KUB 2 allows the user to choose between:

a continuous exposure of the substrate during an adjustable time period,

or to emit light pulses of adjustable duration separated by a time pause also configurable.



Continuous exposure

Set the time

CONTINUOUS MODE	
4" version	

duration is expressed in hours (h), minutes (m), seconds (s) and is adjustable between The 1s and 1h by selecting the numbers/letters on the touchscreen keyboard.

#### WARNING!

It is essential to specify the units, otherwise the system will indicate "Input error!". <u>Ex</u>: 1m30s

Confirm your selection by touching the "V" validation button on the screen, or correct it by touching the "C" correction button as many times as are necessary.







Set the LED transmission power

	CONTINUOUS MODE	
	Duration = 10s	
	Power (in %) = 100	
]	4" version	N
	-	
	KLOÉ	

**Power** is expressed as a percentage of the maximum power emitted by the LED.

It is adjustable between 5 and 100% by selecting the numbers on the keyboard.

#### **GOOD TO KNOW**

There is no unit of measurement, just enter and confirm the value. Ex: 45% can be entered by pressing 4 then 5 then V to validate.

#### **GOOD TO KNOW**

If you want to finally change the duration of exposure, just click the box in front of DURATION with the stylus so you can change the setting. You can thus navigate from one setting to another by clicking the corresponding boxes.



#### Pulse exposure



#### The exposure cycle is defined by successions of light pulses separated by time pauses.

To set a pulse exposure, you must indicate:

- the desired number of pulses: Cycles,
- the light pulse duration: ON Time,
- the pause duration between two pulses: **OFF Time.**

Then adjust the exposure power from 5% to 100%.

#### **GOOD TO KNOW**

By clicking one box with the stylus, one accesses the corresponding setting in order to change it.







Confirm settings

Confirm settings - Continuous exposure

Confirm settings - Pulse exposure





A summary settings menu appears offers to perform three and operations:

> New: returns the user to the menu to choose the exposure cycle. The user can create multiple exposure cycles in succession and store them one after the other without going through the complete exposure setup each time.

> Save: allows the user to store the settings you just entered in the internal memory machine so you can reuse thereafter.

#### **GOOD TO KNOW**

You can store up to ten exposure cycles (pulse or continuous). If all memory locations are free, the boxes will be white with the indication Empty. If you want to save your cycle onto an already existing cycle, you will be asked to override.

**Insolate:** confirms the previously entered settings.

#### **GOOD TO KNOW**

Before launching the exposure, you can open the drawer and check your sample.















Exposure in progress

	EXPOSURE IN PROGRESS CONTINUOUS MODE	C	Ę
	Duration = 10s     Power (in %) = 100	-	- P -
	<ul> <li>Led Temperature = 23°C</li> <li>Wafer Temperature = 23°C</li> </ul>		*
	Time left = 04s		
•			
	4" version		
	<b>4</b> " version		
	4" version		
	4" version		

the screen displays a summary of the exposure settings: During exposure,

- the temperature of the exposure chamber and the LEDs are permanently controlled and displayed,
- a timer lets you know the time remaining prior to the end of exposure.

#### WARNING!

Do not attempt to open the side door during exposure. The power to the machine will be automatically shut off to protect the user from UV radiation, and the exposure cycle will be terminated without possible return or memorization.



#### **Exposure interruption**

	EXPOSURE IN PROGRESS CONTINUOUS MODE	
	Duration = 10s	- N
	• Power (n %) = 100	
	<ul> <li>Led Temperature = 23°C</li> <li>Wafer Temperature = 23°C</li> </ul>	
	Time left = 04s	
4		
	4" version	
1.1		<b>7</b>
-		

#### An exposure can be terminated for three reasons :

- rupture of the power supply,
- machine error: see chapter Troubleshootings: Error messages,
- voluntary user pause.

#### **GOOD TO KNOW**

To stop an exposure, press the emergency stop button on the right of the touch screen. In this case the machine will stop the exposure and will suggest to either restart or cancel the exposure. If you decide to restart the exposure, the UV-KUB will continue the originally defined cycle.







#### Exposure end

- At the end of the exposure, a buzzer sounds two long tones and the screen flashes.
- Simply touch the screen to open the drawer and retrieve the mask and the substrate.

#### **GOOD TO KNOW**

To retrieve the substrate, in the case of a wafer, pass the wafer clamp under the substrate by the recess provided for this purpose in the substrate holder.

Touch the screen to go to the next step.



## LV-KLB Z 4" version



While the drawer is still open, two choices are offered:

- To renew the exposure, with the same settings:
  - load a new substrate in the drawer, then add the photomask,
  - **Continue:** a new exposure will be automatically launched with the identical settings - click on to those of the earlier exposure.
  - If you are finished, simply select **Cancel** to return to the UV-KUB 2 main screen.













# Settings







**LED:** confirms that no transmitter is defective. When you select LED in the "settings" menu, the UV-KUB 2 tests each LED and then displays the result next to the corresponding linde on the list.

- If all is well, the status will show **OK**
- If a problem is detected, the status will show **ERROR**

**Temperature:** displays the exposure chamber and LED temperature.



**Timer:** displays the total run time of each LED during exposure.

Mask Holder: opens the setup menu of the masking distance to ensure proper operation of the device for moving the substrate holder.

**Drawer:** unlocks the drawer

- in order to confirm proper operation
- or to open it for maintenance of the exposure chamber

**Illumination:** measures the substrate holder illumination in mW/cm<sup>2</sup> at full power.

This menu allows you to check the evolution in time of maximum power emitted by the UV-KUB LEDs, and therefore adapt, if necessary, your exposure protocol according to this information.

#### WARNING!

Ensure that there is no substrate on the substrate holder while measuring otherwise the measure value will be wrong.











# Naintenance & troubleshooting





#### **Exterior maintenance**

Use a soft cloth to clean the machine's exterior and cover.

#### WARNING!

Avoid using solvent to clean the touch screen. A soft and dry cloth is recommended. If stains are persistent, turn the screen off and lightly press on the screen with a slightly moist cloth.





#### Exposure chamber maintenance

To properly clean the exposure chamber, open the drawer and turn the machine off via the UV-KUB 2 "settings" and "drawer" menu.

One can then reach the exposure chamber through the side door and completely clean it by accessing the space under the drawer when it is closed.

To clean the chamber components we recommend you use a low aggressive solvent such as Isopropyl Alcohol (IPA).

#### WARNING!

Do not press the optics cover plate when cleaning it inside the exposure chamber. Using a soft cloth to remove any dust will work. To clean the plate, only use Isopropyl Alcohol (no ethanol).







### Troubleshooting

Error messages

During UV-KUB 2 operations, the following error or warning messages may appear:

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ner



Troubleshooting

Possible cause	How to fix the problem?
	Check, at the rear of the machine:
The UV-KUB machine	<ul> <li>the power cable</li> </ul>
	<ul> <li>the position of the switch</li> </ul>
The touchscreen does not respond	Restart the machine.
	Check again the response.
	Check the illumination value in the "settings/lighting" menu.
The exposure seems less	If it's dropped by over 20% of the original value of the machine, transmitters are reaching the end of their life.
efficient with unchanged settings	Contact Kloe customer service.
oottingo	Otherwise, increase the exposure duration or power.

If the problem persists despite the solutions implemented,

contact the Kloe after-sales service : sav@kloe-france.com

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**Exposure-masking system** USER MANUAL - UVK2-4P-2022-01

